



XA-8024E  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Tetsuo TANIGUCHI

Appln. No.: 09/911,619

Group Art Unit: 2851

Filed: July 25, 2001

Examiner: R. Fuller

For: PROJECTION EXPOSURE APPARATUS AND METHOD

Allowed: July 22, 2003

Confirmation No.: 4934

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Attn: Mail Stop Issue Fee

Sir:

Applicant notes that the Examiner's Statement of Reasons for Allowance relates, in particular, to the apparatus claimed, but the allowability of the method claimed is apparent from the Examiner's Statement and from the arguments of record.

Respectfully submitted,

NHS:lmb

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September 30, 2003

By: Nelson H. Shapiro  
Nelson H. Shapiro  
Reg. No. 17,095